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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor: Yoshihisa MATSUBARA et al.

Serial No.: 09/840,386

Filed: April 23, 2001

Title: **METHOD FOR MANUFACTURING SEMICONDUCTOR  
DEVICE, AND PROCESSING SYSTEM AND  
SEMICONDUCTOR DEVICE**

Examiner: Lan Vinh

Group Art Unit: 1765

Confirmation No.: 2510

Attorney Docket No.: 100806-00199 (NEKA 18.612)

November 28, 2005

Mail Stop AF  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

S I R:

In response to the final Office Action issued June 28, 2005, please amend the  
above-captioned application as follows: